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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Kari Härkönen, Mark Doczy, Teemu Lang and Nathan E. Baxter

Application No. 10/642,426

Filed: August 15, 2003

For: DEPOSITION OF CARBON- AND TRANSITION METAL-CONTAINING THIN FILMS

Group Art Unit: 1775

Examiner: Archene A. Turner

Date: December 30, 2004

Confirmation No. 9896

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to:

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December 30, 2004

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RESPONSE TO RESTRICTION REQUIREMENT

TO THE COMMISSIONER FOR PATENTS:

Applicant responds as follows to the December 2, 2004 Office action requiring restriction.

Claims 1-73 are in the application, of which claims 1, 66, 69, and 70 are in independent form. Claims 1-73 stand subject to restriction under 35 U.S.C. § 121. The examiner identified four groups of claims as being directed to the following patentably distinct inventions:

Invention I: Claims 1-63 and 70-73;

Invention II: Claims 64-65;

Invention III: Claims 66-68; and

Invention IV: Claim 69.

Applicant provisionally elects to prosecute the subject matter of Invention I (claims 1-63 and 70-73), without traverse, and withdraws claims 64-69 from consideration at this time.

This response is being submitted within one month of the Office action and no fees should be required. However, if fees are required, the Commissioner is hereby authorized to charge any such fees, or credit overpayment, to Deposit Account No. 19-4455.

Respectfully submitted,

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